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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Hiroji AGA et al.			
				FILING DATE October 15, 2003			
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EXAMINER	<i>Michelle Estrada</i>				DATE CONSIDERED <i>6/23/04</i>	
Examiner:	Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					

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